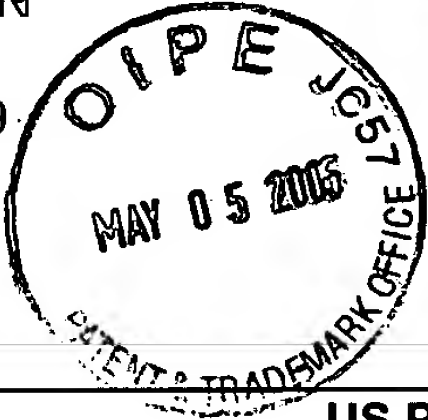


<b>SUPPLEMENTAL INFORMATION DISCLOSURE CITATION</b>  PTO-1449			ATTORNEY'S DOCKET NO.: 2000-039RCE		APPLICATION NO.: 09/840,003	
			APPLICANT: Falcioni et al.			
			FILING DATE: April 19, 2001		GROUP: 1631	CONFIRMATION No. 3082
<b>US PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	2002-0152057	10/17/02	Wang et al.	703	6	12/17/01
	5,143,854	9/1/92	Pirung et al.	436	518	3/7/90
	5,331,573	7/19/94	Balaji et al.	364	500	12/14/90
	5,356,756	10/18/94	Cavicchi et al.	430	315	10/26/92
	5,386,507	1/31/95	Teig et al.	395	161	7/18/91
	5,434,796	7/10/95	Weininger	364	496	6/30/93
	5,526,281	6/11/96	Chapman et al.	364	496	10/28/94
	5,571,639	11/5/96	Hubbell et al.	430	5	5/24/94
	5,854,992	12/29/98	Shakhnovich et al.	702	27	9/26/96
	5,862,514	1/19/99	Huse et al.	702	22	12/6/96
	5,914,891	6/22/99	McAdams et al.	364	578	6/11/97
	5,930,154	7/27/99	Thalhammer-Reyero	364	578	7/8/97
	5,959,297	9/28/99	Weinberg et al.	250	288	10/8/97
	5,980,096	11/9/99	Thalhammer-Reyero	364	578	1/17/95
	6,004,617	12/21/99	Schultz et al.	427	8	6/7/95
	6,030,917	2/29/00	Weinberg et al.	502	104	7/22/97
	6,034,775	3/7/00	McFarland	356	364	10/8/97
	6,045,671	4/4/00	Wu et al.	204	298.11	4/22/97
	6,081,766	6/27/00	Chapman et al.	702	27	5/20/94
	6,144,897	11/7/00	Selliers	700	269	12/9/97
	6,187,164	2/13/01	Warren et al.	205	81	7/20/98
	6,188,965	2/13/01	Mayo et al.	702	27	4/10/98
	6,507,945	1/14/03	Rust et al.	717	103	5/5/99
	6,640,191	10/28/03	Deem et al.	702	19	12/30/99
EXAMINER:			DATE CONSIDERED:			

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.*

<b>SUPPLEMENTAL INFORMATION DISCLOSURE CITATION</b>  PTO-1449			ATTORNEY'S DOCKET NO.:		APPLICATION NO.:	
			2000-039RCE		09/840,003	
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<b>FOREIGN DOCUMENTS</b>						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUB CLASS	TRANSLATION Yes No
	WO 02/04112	1/17/02	PCT	B01J	19/00	X
	WO 96/11878	4/25/96	PCT			
	WO 00/23921	4/27/00	PCT	G06F	17/50	X
<b>OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages Etc.)</b>						
	Briceno et al., SCIENCE 270, pp. 273-275, 1995					
	Danielson et al., "A Combinatorial Approach to the Discovery and Optimization of Luminescent Materials", 30 October 1997, Nature, Vol. 389, No. 30, pp. 944-948					
	Danielson et al., SCIENCE 279, pp. 837-839, 1998					
	Hanak, "The "Multiple-Sample" Concept" in Materials Research: Synthesis, Compositional Analysis and Testing of Entire Multicomponent Systems", © 1970 Chapman and Hall Ltd., pp. 964-971					
	Hsieh-Wilson et al., "Lessons from the Immune System: From Catalysis to Materials Science", © 1996 American Chemical Society, Vol. 29, pp. 164-170					
	Maier, "Combinatorial Chemistry – Challenge and Chance for the Development of New Catalysts and Materials," Angew. Chem. Int. Ed., 1999, 38, 1216					
	Manfred Baerns, et al., "Chemical Reaction Technology", 1987, Georg Thieme Verlag, Stuttgart and New York, Textbook of Technical Chemistry, Vol. 1					
	McFarland and Weinberg, "Approaches for Rapid Materials Discovery Using Combinatorial Methods", 1998, Mat. Tech. Vol. 13.3, pp. 107-120					
	Michalewicz, "Genetic Algorithms + Data Structures = Evolution Programs," 3rd Ed., Springer, Berlin, Germany, 1996					
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	Xiang et al., "A Combinatorial Approach to Materials Discovery", 23 June 1995, Science, Vol. 268, pp. 1738-1470					
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